

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

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Docket Number (Optional)

100-23700 (P05749)

Application Number

New

Applicant(s)

Peter J. Hopper et al.

Filing Date

Herewith

Group Art Unit

Unknown

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DL		U.S. Appln. 10/290,138		Padmanabhan et al.			11/06/02
		6,440,801 B1	08/27/02	Furukawa et al.	438	272	06/28/00
		5,578,850	11/26/96	Fitch et al.	257	329	01/16/96
		4,871,684	10/03/89	Glang et al.	437	31	10/29/87
		6,504,210 B1	01/07/03	Divakaruni et al.	257	344	06/23/00
		5,963,800	10/05/99	Augusto	438	212	06/17/96
		5,170,243	12/08/92	Dhong et al.	365	208	11/04/91
		6,337,497 B1	01/08/02	Hanafi et al.	257	306	05/16/97
		6,204,532 B1	03/20/01	Gambino et al.	257	329	10/05/99
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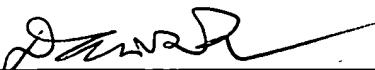
FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

DL		H. Pein and James D. Plummer, "Performance of the 3-D PENCIL Flash EPROM Cell and Memory Array", IEEE Transactions on Electron Devices, Volume 42, No. 11, 1995, pp. 1982-1991.
DL		H. Pein and James D. Plummer, "A 3-D Sidewall Flash EPROM Cell and Memory Array", Electron Device Letters, Volume 14, (8), 1993, pps. 415-417.

EXAMINER



DATE CONSIDERED

4/4/05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				ATTY DOCKET NO. 100-23700 (P05749)		SERIAL NO. New	
				Peter J. Hopper et al.			
				FILING Herewith		GROUP Unknown	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DR		5,504,359	04/02/96	Rodder	257	329	01/06/95
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		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
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DR			U. Simu et al., "Limits in Micro Replication of CVD Diamond By Moulding Technique", 1997, [online], [retrieved on 2003-11-16]. Retrieved from the Internet: <URL: http://www.angstrom.uu.se/solidstatephysics/joakim/limits.pdf>. pp. 1-11, (note page 5, column 2, lines 15-23).				
DR			E. Hui et al., "Carbonized Parylene as a Conformal Sacrificial Layer", [online], [retrieved on 2003-11-16]. Retrieved from the Internet: <URL: http://www-bsac.eecs.berkeley.edu/archive/users/hui-elliot/pdf/sacpaper.pdf>. pp 1-5 (unnumbered), (note page 2, Process Characterization, first paragraph).				
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